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Docket No.: M4065.0466/P466  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Neal Rueger

Application No.: 09/938,644

Art Unit: 1765

Filed: August 27, 2001

Examiner: T. Mackey

For: METHOD AND APPARATUS FOR  
MICROMACHINING USING A MAGNETIC  
FIELD AND PLASMA ETCHING

AMENDMENT

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated April 15, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.

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